Docket No.: 2336-254 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Sun Woon KIM et al.

U.S. Patent Application No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: Herewith

For: FABRICATION METHOD OF NITRIDE SEMICONDUCTORS AND NITRIDE

SEMICONDUCTOR STRUCTURE FABRICATED THEREBY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The attached references appear in the specification.

Respectfully submitted

LOWE HAUPTMAN GILMAN & BERNER, LLP

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Date: March 23, 2004

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				APPLICANT				
	APPLIC	ATION		Sun Woon KIM et al.				
				FILING DATE herewith		GROUP Not yet assigned		
(PTO-1449)								
	U.S. PATENT DOCUMENTS							, -
EXAMINER'S INITIALS	PATENT NO. DATE						FII	LING
	5,290,393		NAME		CLASS	SUBCLASS	B	ATE
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.